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SERIAL NUMBER 10/695,804	FILING DATE 10/30/2003 RULE	CLASS 438	GROUP ART UNIT 2814	ATTORNEY DOCKET NO. 740819-1028
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APPLICANTS
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** CONTINUING DATA *****
 This application is a DIV of 09/790,518 02/23/2001 ABN ✓ A.M O.K.

** FOREIGN APPLICATIONS *****
 JAPAN 2000-045504 02/23/2000 ✓ A.M O.K.

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
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Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY JAPAN	SHEETS DRAWING 11	TOTAL CLAIMS 19	INDEPENDENT CLAIMS 2
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Verified and Acknowledged
 Examiner's Signature _____ Initials **A.M.**

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 22204
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TITLE **METHOD FOR FABRICATING METAL INTERCONNECT IN A CARBON-CONTAINING SILICON OXIDE FILM.**
~~Semiconductor device and method for fabricating the same~~

FILING FEE RECEIVED 788	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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